



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Yoshikazu IBARA et al.

Group Art Unit: 2823

Serial Number: 09/892,893

Examiner: William D. COLEMAN

Filed: June 28, 2001

Confirmation No.: 1585

For: METHOD FOR MANUFACTURING SEMICONDUCTOR DEVICES
WITH SILICIDE FILMS THEREON

Customer No. 38834

AMENDMENT UNDER 37 C.F.R. §1.111

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

January 12, 2004

Sir:

Applicants respond herein to the October 10, 2003 Office Action.

Please amend the above-identified application as follows:

Amendments to the Specification appear on page 2.

Amendments to the Claims appear in the listing of claims that begins on page 3.

Remarks begin on page 6.